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U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
/SJF/ _____ _____	AA AB	6,333,202	J.W. Adkisson, et al.	12/25/01		

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
/SJF/ _____ _____	AC AD	2001-102543	04/13/01 Japan Yes-Abstract/Discussed in the specification

OTHER DOCUMENTS

<u>/SJF/</u>	AE	Patent Abstracts of Japan, Publication Number 8-186235, dated July 16, 1996.
<u>/SJF/</u>	AF	Patent Abstracts of Japan, Publication Number 8-227980, dated September 3, 1996.
<u>/SJF/</u>	AG	L. Tsakalakos, et al.; "Excimer Laser Liftoff of Epitaxial Pb(Zr, Ti)O ₃ Thin Films and Heterostructures;" <i>Mat. Res. Soc. Symp. Proc.</i> ; Vol. 596; 2000; pp. 549-556.
<u>/SJF/</u>	AH	B. K. Moon, et al.; "Characteristics of ferroelectric Pb(Zr,Ti)O ₃ films epitaxially grown on CeO ₂ (111)/Si(111) substrates; <i>Thin Solid Films</i> ; Vol. 385; 2001; pp. 307-310.
Examiner /Steven J. Fulk/ Date Considered 06/21/2007		